



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 21, 2026	
IGI Report Number	LG825669252
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ANTIQUE CUSHION CUT
Measurements	9.65 X 6.76 X 4.45 MM

GRADING RESULTS

Carat Weight	2.44 CARATS
Color Grade	E
Clarity Grade	VS 2

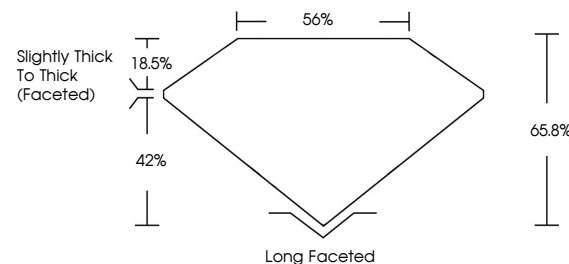
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG825669252

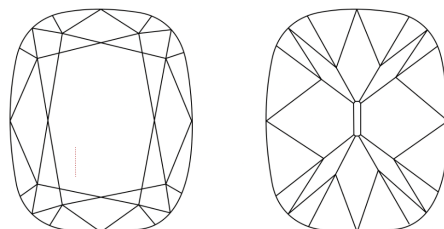
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG825669252
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

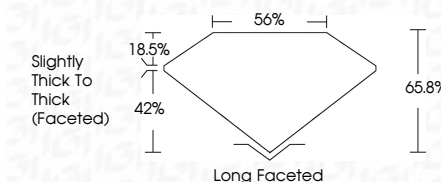
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www.igi.org

August 21, 2006	2.44 CARATS
GI Report No. LG826549262	E
INTRIQUE CUSHION CUT	VS 2
65 X 7.6 X 4.45 MM	66.5%
	56%
	Slightly Thick to Thick (Faceted)
	Long Faceted
	EXCELLENT
	EXCELLENT
	NONE
	1691 LG826549262

Comments: This is a Very Gray Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa